



Practitioner's Docket No. 081468-0304800
Client Reference: P-0342.010-US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: JAN EVERET VAN DER WERF et al.

Application No.: 10/618,264
Filed: July 14, 2003

Confirmation No.: 3943
Group No.: 2878
Examiner:

For: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET
37 C.F.R. § 1.76(c)

The following information on the Application Data Sheet is changed as indicated:

BIBLIOGRAPHIC DATA

1. Assignee information is being modified.

The assignee(s) of this application is/are:

ASML NETHERLANDS B.V.
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Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST

Date: June 3, 2004

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